



AP
CH
IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Manabu NAKAMURA et al.**

Group Art Unit: **2891**

Serial Number: **10/659,748**

Examiner: **Bradley Smith**

Filed: **September 11, 2003**

Confirmation Number: **3468**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE
HAVING GATE OR TUNNEL INSULATION FILM**

Attorney Docket Number: **031140**
Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

March 16, 2006

Sir:

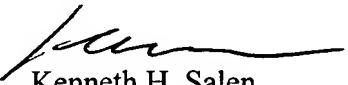
Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated November 18, 2005 for one month from February 18, 2006 to March 18, 2006.

Attached please find a check in the amount of \$120.00 for the cost of the extension.

If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP


Kenneth H. Salen
Attorney for Applicants
Registration No. 43,077
Telephone: (202) 822-1100
Facsimile: (202) 822-1111

03/17/2006 SZEWDIE1 00000032 10659748
01 FC:1251

120.00 op

KHS/rf